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## BIB DATA SHEET

CONFIRMATION NO. 6935

<b>SERIAL NUMBER</b> 10/695,770	<b>FILING or 371(c) DATE</b> 10/30/2003 <b>RULE</b>	<b>CLASS</b> 134	<b>GROUP ART UNIT</b> 1711	<b>ATTORNEY DOCKET NO.</b> SEC.1101		
<b>APPLICANTS</b> Ki-Hwan Park, Suwon-City, KOREA, REPUBLIC OF; Tae-Joon Kim, Suwon-City, KOREA, REPUBLIC OF; Young-Choul Kook, Suwon-City, KOREA, REPUBLIC OF; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2002-69630 11/11/2002 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 01/29/2004						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /FRANKIE L STINSON/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWINGS</b> 6	<b>TOTAL CLAIMS</b> 10	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> VOLENTINE & WHITT PLLC ONE FREEDOM SQUARE 11951 FREEDOM DRIVE SUITE 1260 RESTON, VA 20190 UNITED STATES						
<b>TITLE</b> Method of and apparatus for cleaning semiconductor wafers						
<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			